

UNITED STATES PATENT AND TRADEMARK OFFICE



UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, Virginia 22313-1450 www.uspto.gov

| APPLICATION NO. | FILING DATE | FIRST NAMED INVENTOR | ATTORNEY DOCKET NO. | CONFIRMATION NO. | |
|--------------------------------|--|----------------------|---------------------|-------------------------|--|
| 10/642,969 | 08/18/2003 | Darius L. Crenshaw | TI-29906.1 | TI-29906.1 3382 | |
| 23494 | 7590 03/30/2005 | | EXAMINER | | |
| TEXAS INSTRUMENTS INCORPORATED | | | NHU, DAVID | | |
| | P O BOX 655474, M/S 3999 DALLAS, TX 75265 | | ART UNIT | PAPER NUMBER | |
| | | | 2818 | | |
| | | | | DATE MAILED: 03/30/2005 | |

Please find below and/or attached an Office communication concerning this application or proceeding.

| | Application No. | Applicant(s) | | | |
|---|---|--|--|--|--|
| | 10/642,969 | CRENSHAW ET AL. | | | |
| Office Action Summary | Examiner | Art Unit | | | |
| | David Nhu | 2818 | | | |
| The MAILING DATE of this communication app Period for Reply | ears on the cover sheet with the c | orrespondence address | | | |
| A SHORTENED STATUTORY PERIOD FOR REPLY THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a reply If NO period for reply is specified above, the maximum statutory period work. Failure to reply within the set or extended period for reply will, by statute, Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b). | i6(a). In no event, however, may a reply be time within the statutory minimum of thirty (30) days ill apply and will expire SIX (6) MONTHS from cause the application to become ABANDONE | nely filed s will be considered timely. the mailing date of this communication. C (35 U.S.C. § 133). | | | |
| Status | | | | | |
| 1)⊠ Responsive to communication(s) filed on <u>02 Ma</u> | arch 2005. | | | | |
| , | | | | | |
| 3) Since this application is in condition for allowan | Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213. | | | | |
| Disposition of Claims | | | | | |
| 4) Claim(s) 1-20 is/are pending in the application. 4a) Of the above claim(s) 1-11 is/are withdrawn 5) Claim(s) is/are allowed. 6) Claim(s) 12-20 is/are rejected. 7) Claim(s) is/are objected to. 8) Claim(s) are subject to restriction and/or | | | | | |
| Application Papers | | | | | |
| 9) The specification is objected to by the Examiner. | | | | | |
| 10) ☐ The drawing(s) filed on is/are: a) ☐ accepted or b) ☐ objected to by the Examiner. | | | | | |
| Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a). | | | | | |
| Replacement drawing sheet(s) including the correction 11) The oath or declaration is objected to by the Ex | | | | | |
| Priority under 35 U.S.C. § 119 | | | | | |
| 12) ☑ Acknowledgment is made of a claim for foreign a) ☐ All b) ☐ Some * c) ☐ None of: 1. ☐ Certified copies of the priority documents 2. ☑ Certified copies of the priority documents 3. ☐ Copies of the certified copies of the priority application from the International Bureau | s have been received. s have been received in Application ity documents have been receive | on No. <u>09/941,031</u> . | | | |
| * See the attached detailed Office action for a list of the certified copies not received. | | | | | |
| | Daw | Rl | | | |
| Attachment(s) | | | | | |
| Notice of References Cited (PTO-892) Notice of Draftsperson's Patent Drawing Review (PTO-948) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date | 4) Interview Summary Paper No(s)/Mail Da 5) Notice of Informal P 6) Other: | | | | |

DETAILED ACTIONS

Claims Objection

1. Claims 12-20, "a RF switch fabricated by a method of integrating a resistor in circuit with a bottom electrode of a micro-electromechanical switch on a substrate..." are rejected by a Product-by-Process claim. See MPEP 2113.

Claim Rejections - 35 USC § 102

2. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- 3. Claims 12-20 are rejected under 35 U.S.C. 102(b) as being anticipated by Linn et al (5,547,896).

Regarding claim 12, Linn, (see figures 1a-1f, 2a-2b, 3a-3b, col. 2, lines 59-67, col. 3, lines 1-67, col. 4, lines 1-67), teaches a RF switch fabricated by a method of integrating a resistor in circuit with a bottom electrode of a micro-electromechanical switch on a substrate 14, said method comprising the steps of: depositing a uniform layer of a resistor material 12 over at least one side of said substrate; depositing a uniform layer of a hard mask material 10 over said resistor material; depositing a uniform layer of a metal material 18 over said hard mask material, wherein said deposited layers form a stack 10, 12; patterning and etching a bottom electrode 18 and resistor lengths 12 from said stack; and etching said hard mask 10, 22 and metal material 18 from said patterned resistor lengths.

Regarding claims 13-20, Linn, (see figures 1-3, col. 1-6), also teach patterning and etching said deposited dielectric to correspond to said pattern bottom electrode and resistor lengths;

Application/Control Number: 10/642,969

Art Unit: 2818

wherein said resistor material comprises NiCr; etching acts comprises wet etching; the hard mask and metal material remain substantially covering said patterned bottom electrode subsequently to said etching said hard mask and material from said patterned resistor length; the metal material comprises aluminum – silicon; the anchor/hole/opening comprises silicon oxide.

Conclusion

- 4. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure: Liao'841, Mitchell'679, Tang'346 are cited as of interest.
- 5. A shortened statutory period for response to this action is set to expired 3 (three) months from the date of this letter. Failure to respond within the period for response will cause the application to become abandoned (see 710.02 (b)).
- 6. Any inquiry concerning this communication on earlier communications from the examiner should be directed to David Nhu, (571)272-1792. The examiner can normally be reached on Monday-Friday from 7:30 AM to 5:00 PM. The examiner's supervisor, David Nelms can be reached on (571)272-1787.

The fax phone number for the organization where this application or proceeding is assigned is (703)872-9306.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0956.

Information regarding the status of an application may be obtained from the patent application information retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR

Application/Control Number: 10/642,969

Art Unit: 2818

system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private

Page 4

PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

David Nhu

Art Unit: 2818